

<b>Form 1449 (Modified)</b>		<b>Atty. Docket No.</b> HIT1P027 / HSJ9-2003-0150US1	<b>Application No.:</b> <u>Unassigned</u> 10/717128
<b>Information Disclosure Statement By Applicant</b>  (Use Several Sheets if Necessary)		<b>Applicant:</b> J. Mac Freitag et al. <b>Filing Date:</b> Herewith	<b>Group Art Unit:</b> <u>Unassigned</u> 1762

**U.S. Patent Documents**

Examiner Initial	No.	Patent No.	Date	Patentee	Class	Sub-class	Filing Date
	A	2003/0035253	02/20/2003	Lin et al.	360	324	08/17/2001
	B	2002/0085320	07/04/2002	Gill	360	324.11	01/04/2001
	C	6,143,380	07/02/2002	Pinarbasi	204	192.11	08/14/2000
	D	6,404,606	06/11/2002	Pinarbasi	360	324.11	11/05/1999
	E	2002/0048127	04/25/2002	Fukuzawa et al.	360	324.1	09/04/2001
	F	6,317,299	11/13/2001	Pinarbasi	360	324.11	02/17/2000
	G	6,086,727	07/11/2000	Pinarbasi	204	192.11	06/05/1998
	H	6,063,244	05/16/2000	Pinarbasi	204	192.11	05/21/1998
	I						
	J						
	K						
	L						

**Foreign Patent or Published Foreign Patent Application**

Examiner Initial	No.	Document No.	Publication Date	Country or Patent Office	Class	Sub-class	Translation Yes	No
	M	11-144956	28.05.1999	Japan	H01F	10/16	X	
	N	9069211	11.03.1997	Japan	G11B	5/39	X	
	O							
	P							

**Other Documents**

Examiner Initial	No.	Author, Title, Date, Place (e.g. Journal) of Publication
	R	Lee, W. Y. et al., "Effects of Mn Concentration and Deposition Temperature on the Giant Magnetoresistive Properties of Ion-Beam-Deposited PtMn Spin Valves", IEE Transactions on Magnetics, Vol. 38, No. 5, September 2002 pp 3536 - 3539
	S	Sant, S. et al.. "Giant Magnetoresistance in Ion Beam Deposited Spin-Valve Films with Specular Enhancement", Journal of Applied Physics, Volume 89, Number 11, June 1, 2001. pp 6931 - 6933
Examiner	T	Date Considered <i>8/8/02</i>

Examiner: Initial citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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